

1. Explain why electronic doping by introduction of suitable donor/acceptor levels in an amorphous material is difficult.

Electronic doping is difficult in amorphous materials due to the high concentration of intrinsic states in the gap [1]. When dopants are added, the concentration of introduced states is low compared to the intrinsic states, making it difficult to move the Fermi level. Additionally, with their low coordination number and flexibility, amorphous materials can undergo relaxation when dopants are added [2]. This traps the added charge carriers instead of producing a system with more free carriers. This can be modeled with VAPs, which can use the added carriers to change the charge of their dangling bond [3]. To introduce a large enough number of states to move the Fermi level, the number of dopants must be at least double the number of VAP defects [3].

2. Explain why the doping discussed in problem (1) might not improve carrier mobility.

Doping introduces charged defects, D^+ and D^- , and though these defects are only capable of trapping either electrons *or* holes respectively, they are much more effective trap sites than D^0 [4]. Street et al. found D^+ centers were 5 times more effective than D^0 centers at trapping electrons and D^- centers were 2-4 times more effective at trapping holes than D^0 centers. Similarly, Kazakova and Tsendin [5] found that when the number of dopants is 2 to 3 times the number of defect centers, hole mobility decreases as dopant concentration increases.

- [5] trapping at negative defect centers likely limits hole drift mobility

3. Would you expect to see blocking contacts in a metal-amorphous semiconductor contact? Explain your answer.
4. Describe the structural order giving rise to extended (delocalized) states and localized states in an amorphous semiconductor.
5. Provide definitions/explanations of the following:
 - Hubbard correlation energy
 - Localization length
 - Anderson transition
 - Localized “in the Anderson sense”
6. (a) What is the difference between variable range hopping and nearest neighbor hopping?
(b) In which type of conduction will tunneling occur?

References

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